

FORM PTO-1449  
(REV. 7-80)  
(Title Amended 3/83)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.  
125397

SERIAL NO.  
10/065,018

INFORMATION DISCLOSURE STATEMENT BY APPLICANT--  
LIST OF ITEMS

Applicant

Marc (nmn) Schaepkens et al.

Filing Date

9/11/02

Group

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
82	AA 6 2 6 8 6 9 5	07/31/01	Affinito			
82	AB 3 9 3 2 6 9 3	01/13/76	Shaw et al.			
82	AC 5 9 9 8 8 0 3	12/07/99	Forrest et al.			
82	AD 6 0 2 3 3 7 1	02/08/00	Onitsuka et al.			
82	AE 4 5 4 0 7 6 3	09/10/85	Kirchhoff			
82	AF 5 1 8 5 3 9 1	02/09/93	Stokich, Jr.			
	AG					
	AH					
	AI					
	AJ					
	AK					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	No
82	AL 0 0 2 6 9 7 3	08/27/80	EP				
82	AM 0 1 8 1 6 4 9	09/13/85	EP				
82	AN 0 1 8 2 3 3 6	04/20/00	EP				
	AO						
	AP						

OTHER INFORMATION (Including Author, Title, Date, Pertinent pages. Etc.)

82	AR	H. Suzuki et al., "Near-Ultraviolet Electroluminescence from Polysilanes 331 Thin Solid Films 64-70 (1998).
82	AS	Gijsbert Jan Meeusen, "Plasma Beam Deposition of Amorphous Hydrogenated Silicon," Thesis, University of Eindhoven, pp. 16-19 (1994).
82	AT	Bastiaan Arie Korevaar, "Integration of Expanding Thermal Plasma Deposited Hydrogenated Amorphous Silicon in Solar Cells," Thesis, University of Eindhoven, pp. 23-34 (2002).

EXAMINER

*Schaepkens*

DATE CONSIDERED

1/30/04

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	BA					
	BB					
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	BK					

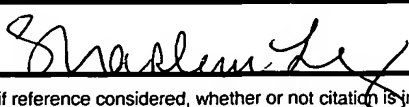
## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	No
	BL						
	BM						
	BN						
	BO						
	BP						

## OTHER INFORMATION (Including Author, Title, Date, Pertinent pages. Etc.)

BR	V.J. Law et al., "RF Probe Technology for the Next Generation of Technological Plasmas," J. Phys. D: Appl. Phys., 34, 2726-2733 (2001).
BS	
BT	

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